PATENT Atly. Dkl. No. AMAT/4714.P1/W&T/WCVD/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Xi et al.

Serial No.: 09/678,266

Confirmation No.: 4642

Filed:

October 3, 2000

For.

Method and Apparatus for

Depositing Refractory Metal Layers Employing Sequential Deposition Techniques to Form a Nucleation Layer

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 2827

Examiner:

Zameke, D.

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MAY 0 6 2002

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CERTIFICATE OF FAX 37 C.F.R. 1.8

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May 6, 2002

B. Todd Patte

RESPONSE TO OFFICE ACTION DATED APRIL 23, 2002

In response to the Office Action dated April 23, 2002, having a shortened statutory period for response set to expire on May 23, 2002, Applicants elect claims 1-14, identified as Invention 1 by the Examiner, with traverse.

THE PENDING CLAIMS:

1. A method for forming a layer on a substrate disposed in a processing chamber, said method comprising:

forming a nucleation layer by serially exposing said substrate to first and second reactive gases; and

forming atop of said nucleation layer, a bulk deposition layer employing vapor deposition to subject said nucleation layer to a bulk deposition of a compound contained in one of said first and second reactive gases.



Attorneys at Law
3040 Post Oak Boulevard, Suite 1500
Houston, Texas 77056-6582
Telephone (713) 623-4844
Facsimile (713) 623-4846
www.mpslip.com

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DATE:	May 6, 2002	FILE NO:	AMAT/4714.P1/W&T/WCVD/RKK		
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RESPONSE TO FINAL OFFICE ACTION DATED APRIL 23, 2002

U.S. Serial No.:

09/678,266

Filing Date:

October 3, 2000

Inventor:

Xi et al.

Examiner:

David Zarneke

Group Art Unit:

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